1. Record Nr. UNISA996386814403316

Titolo	An impartial relation of the surrender and delivery of the famous city of Dublin to the French by the late King James [[electronic resource]] : with some great and remarkable passages, which happened betwixt Teague O Regan and the English General, at the surrender, &c
Pubbl/distr/stampa	London, : Printed for R. Hayhurst ..., [1690]
Descrizione fisica	2 p
Altri autori (Persone)	W. B
Soggetti	Dublin (Ireland) History, Military Ireland History War of 1689-1691
Lingua di pubblicazione	Inglese
Formato	Materiale a stampa
Livello bibliografico	Monografia
Note generali	Caption title. Signed on p. 2: W.B. "Licensed May 22d. J. Fraiser. 1690. And entered according to order" Date of publication from Wing. Advertisement on p. 2. Reproduction of original in Huntington Library.
Sommario/riassunto	eebo-0113

2. Record Nr. UNISA996212922703316

Titolo	Advanced dielectric, piezoelectric and ferroelectric thin films [[electronic resource]] : proceedings of the 106th Annual Meeting of the American Ceramic Society, Indianapolis, Indiana, USA (2004) / / editors, Bruce A. Tuttle ... [et al.]
Pubbl/distr/stampa	Westerville, Ohio, : American Ceramic Society, c2005
ISBN	1-280-67391-5 9786613650849 1-118-40720-2 1-118-40722-9
Descrizione fisica	1 online resource (98 p.)
Collana	Ceramic transactions ; ; v. 162
Altri autori (Persone)	TuttleBruce
Disciplina	621.3815/2 621.38152
Soggetti	Thin films - Materials Thin film devices
Lingua di pubblicazione	Inglese
Formato	Materiale a stampa
Livello bibliografico	Monografia
Note generali	"... selected papers from the Advanced Dielectric, Piezoelectric and Ferroelectric Thin Films Symposium held at the American Ceramic Society's 106th Annual Meeting, April 18-21, 2004 in Indianapolis, Indiana."--p. vii.
Nota di bibliografia	Includes bibliographical references and indexes.
Nota di contenuto	Advanced Dielectric, Piezoelectric and Ferroelectric Thin Films; Contents; Preface; Chemical Solution Deposition of CaCu3Ti4O12 Thin Films; The Temporal Effects in DC-Biased PbNb(Zr,Sn,Ti)O3; High Energy Density PLZT Thin Film Capacitors; Reliability Studies on Sputter Deposited Barium Strontium Titanate Thin Film Capacitors; Raman Study of Effects of Excess Bi Content in Metalorganic Derived Bi4Ti3O12 Films; High Dielectric Tunability Ferroelectric (Pb,Sr)TiO3 Thin Films for Room Temperature Tunable Microwave Devices; Fabrication of Self-Assembled Nanostrutures of Microwave Dielectrics Epitaxial Phase Selection in the Rare Earth Manganite SystemMulti-Ferroic BiFeO3 Films Prepared by Liquid Phase Epitaxy and Sol-Gel Methods; Effect of Argon Addition During ECR Mode Nucleation of Diamond Films Grown by MPCVD; Author Index; Keyword Index

Sommario/riassunto

Advances in synthesis and characterization of dielectric, piezoelectric and ferroelectric thin films are included in this volume. Dielectric, piezoelectric and ferroelectric thin films have a tremendous impact on a variety of commercial and military systems including tunable microwave devices, memories, MEMS devices, actuators and sensors. Recent work on piezoelectric characterization, AFE to FE dielectric phase transformation dielectrics, solution and vapor deposited thin films, and materials integration are among the topics included. Novel approaches to nanostructuring, characterization of m